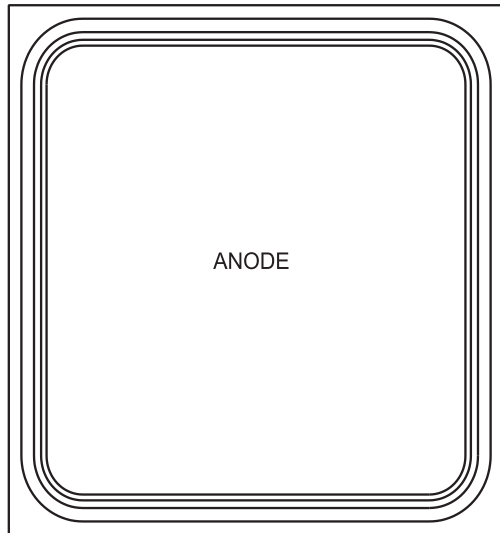


**PROCESS DETAILS**

Die Size	72.5 x 72.5 MILS
Die Thickness	11.8 MILS
Anode Bonding Pad Area	63.8 x 63.8 MILS
Top Side Metalization	Al - 30,000Å
Back Side Metalization	Au - 18,000Å

**GEOMETRY**



BACKSIDE CATHODE

R0

**GROSS DIE PER 4 INCH WAFER**

2,178

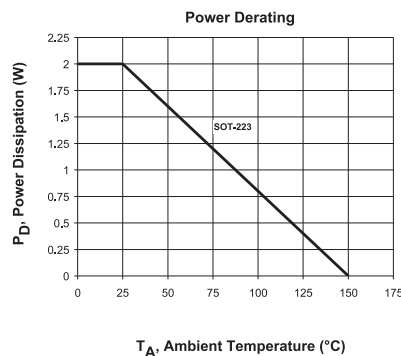
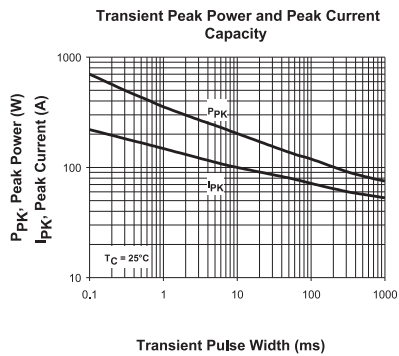
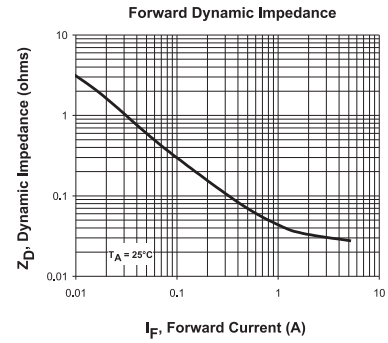
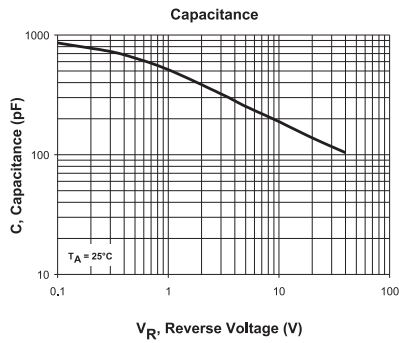
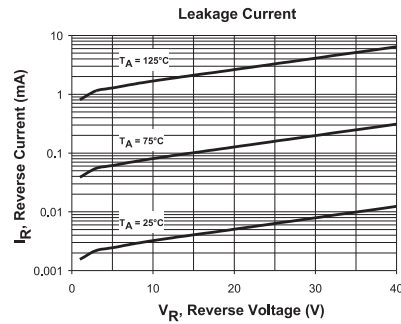
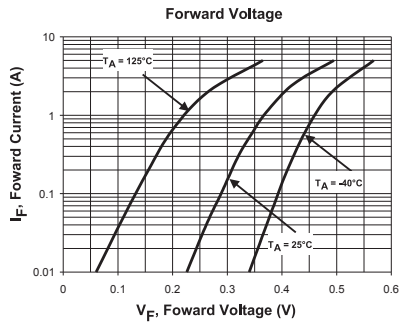
**PRINCIPAL DEVICE TYPES**

CZSH5-40

CZSH10-40CN (Dual Chip)

145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
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